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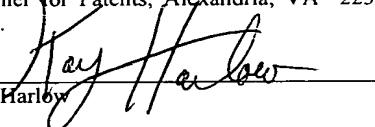
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of )  
LEE et al. ) Examiner: Nguyen, G.  
Application No. 10/674,319 ) Art Unit: 3723  
Filed: September 29, 2003 ) Docket No. LAM2P434  
For: METHOD AND APPARATUS OF A ) Date: January 18, 2005  
VARIABLE HEIGHT AND CONTROLLED )  
FLUID FLOW PLATEN IN A CHEMICAL )  
MECHANICAL POLISHING SYSTEM )

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, Alexandria, VA 22313-1450 on January 18, 2005.

Signed: 

Kay Harlow

RESPONSE TO RESTRICTION REQUIREMENT

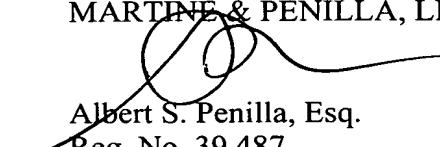
Commissioner for Patents  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Restriction Requirement dated December 21, 2004, Applicants hereby elect to prosecute, without traverse, Species I, claims 1-7, 11-18, 22, and 25-29 (Figures 3-4c) in the above-identified Patent Application.

Applicants believe that no fees are required in the filing of this Response. However, if it is determined that any fees are required, the Commissioner is authorized to charge such fees to our Deposit Account No. 50-0805 (Order No. LAM2P434). Should the Examiner have any questions concerning this matter, the undersigned can be reached at the telephone number set out below.

Respectfully submitted,  
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